4

PALM INTRANET

Day: Friday Date: 9/24/2004

Time: 09:49:35

Inventor Name Search Result

Your Search was:

Last Name = PYO First Name = SUNG 09/879,204

Application#	Patent#	Status	Date Filed	Title	Inventor Name 33
10878315	Not Issued	030	06/29/2004	RADIO FREQUENCY SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME	PYO, SUNG GYU
10878314	Not Issued	020	06/29/2004	METHOD FOR FORMING INDUCTOR IN SEMICONDUCTOR DEVICE	PYO, SUNG GYU
10731478	Not Issued	030		METHOD FOR FORMING INDUCTOR IN SEMICONDUCTOR DEVICE	PYO, SUNG GYU
10697320	Not Issued	030	10/31/2003	CU FILM DEPOSITION EQUIPMENT OF SEMICONDUCTOR DEVICE	PYO, SUNG GYU
10162873	Not Issued	041	06/06/2002	CHEMICAL ENHANCER TREATMENT CHAMBER AND A CU, THIN FILM DEPOSITION APPARATUS OF A SEMICONDUCTOR DEVICE USING THE SAME	PYO, SUNG GYU
10157137	Not Issued	092	05/30/2002	METHOD FOR FORMING DIFFUSION BARRIER FILM OF SEMICONDUCTOR DEVICE	PYO, SUNG GYU
10156839	6664636	150		CU FILM DEPOSITION EQUIPMENT OF SEMICONDUCTOR DEVICE	PYO, SUNG GYU
10079115	<u>6617238</u>	150		METHOD OF MANUFACTURING A METAL WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09983668	6551932	150		METHOD FOR FORMING METAL LINE IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
ļ					

h e eb cg b e f

q

09888539	6528415	150	06/26/200	METHOD OF FORMING A METAL LINE IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09883964	6627523	150		METHOD OF FORMING A METAL WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09883242	Not Issued	161	06/19/2001	SHOWERHEAD AND LIQUID RAW MATERIAL SUPPLY APPARATUS USING THE SAME	PYO, SUNG GYU
<u>09880816</u>	6468907	150	06/15/2001	METHOD OF MANUFACTURING A COPPER WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09880815	6413864	150	06/15/2001	METHOD OF MANUFACTURING A COPPER METAL WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09880810	Not Issued	161	06/15/2001	SHOWERHEAD IN CHEMICAL-ENHANCED CHEMICAL VAPOR DEPOSITION EQUIPMENT	PYO, SUNG GYU
09879324	Not Issued	161	06/12/2001	METHOD OF MANUFACTURING A METAL LINE IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09879204	Not Issued	030		HEATER BLOCK HAVING CATALYST SPRAY MEANS	PYO, SUNG GYU
09875698	6723645	150		METHOD OF FORMING A METAL WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09875625	6645858	150		METHOD OF CATALYZING COPPER DEPOSITION IN A DAMASCENE STRUCTURE BY PLASMA TREATING THE BARRIER LAYER AND THEN APPLYING A CATALYST SUCH AS IODINE OR IODINE COMPOUNDS TO THE BARRIER LAYER	PYO, SUNG GYU
09875623	6436826	150		METHOD OF FORMING A METAL WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
<u>09875621</u>	6376356	150		METHOD OF MANUFACTURING A METAL WIRING IN A	PYO, SUNG GYU

e

h e eb cg b e f

				SEMICONDUCTOR DEVICE	
09874505	659323	6 150	06/05/200	1 METHOD OF FORMING A METAL WIRING IN A SEMICONDUCTOR DEVICE WITH COPPER SEED	PYO, SUNG GYU
09837595	6553859	9 150	04/18/200	POWER SHIFT DEVICE OF TRANSMISSION FOR VEHICLE	PYO, SUNG-YONG
09821979	Not Issued	161	03/30/200	APPARATUS FOR SUPPLYING A LIQUID RAW MATERIAL AND METHOD OF MANUFACTURING A COPPER LAYER USING THE SAME	
09722031	Not Issued	161	11/27/2000	DUPLEX ZONE SHOWERHEAD AND CHEMICAL ENHANCED CHEMICAL VAPOR DEPOSITION EQUIPMENT UTILIZING THE SAME	PYO, SUNG GYU
09721968	6337276		11/27/2000	METHODS OF FORMING A COPPER WIRING IN A SEMICONDUCTOR DEVICE USING CHEMICAL VAPOR DEPOSITION	PYO, SUNG GYU
09721967	6492268	150	11/27/2000	METHOD OF FORMING A COPPER WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09704741	Not Issued	161	,	METHOD OF FORMING A METAL WIRING IN A SEMICONDUCTOR	PYO, SUNG GYU
09488521	6346478	150]	METHOD OF FORMING A COPPER WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09428049	6349887	150	10/27/1999	LIQUID DELIVERY SYSTEM	PYO, SUNG GYU
<u>08605206</u>	Not Issued	161	12/05/1996	NOVEL THIAZOLIDIN-4-ONE DERIVATIVES	PYO , SUNG S.
08500799	Not Issued	161		GRANULOCYTE ASSAY METHODS AND APPARATUS	PYO , SUNG H.
08366594	5541183	150	12/29/1994	GINKGOLIDE DERIVATIVES	PYO, SUNGSOO

Inventor Search Completed: No Records to Display.

Last Name

First Name

Search Another: Inventor